

<b>INFORMATION DISCLOSURE CITATION</b> <small>(Use several sheets if necessary)</small>				Docket Number (Optional) <b>FIS920030273US1</b>		Application Number <b>10/709,321</b>	
				Applicant(s) <b>Andricacos et al.</b>			
				Filing Date <b>4/28/04</b>		Group Art Unit	
<b>U.S. PATENT DOCUMENTS</b>							
EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<b>FOREIGN PATENT DOCUMENTS</b>							
REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
<b>OTHER DOCUMENTS</b> <i>(Including Author, Title, Date, Pertinent Pages, Etc.)</i>							
RJ		"Microstructure/Mechanical Properties Relationship in Electrodeposited Ni/Cu Nanolaminates," F. Ebrahimi et al., Materials Science and Engineering A301 (2001) pp. 23-34.					
EXAMINER <i>Ron Pompey</i>				DATE CONSIDERED <i>10-20-05</i>			

**EXAMINER:** Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.